REGISTRATION TO PRACTICE

The following list contains the names of persons seeking for registration to practice before the United States Patent and Trademark Office. Final approval for registration is subject to establishing to the satisfaction of the Director of the Office of Enrollment and Discipline that the person seeking registration is of good moral character and repute. 37 CFR § 11.7. Accordingly, any information tending to affect the eligibility of any of the following persons on moral ethical or other grounds should be furnished to the Director of Enrollment and Discipline on or before May 31, 2024 at the following address: Mail Stop OED, United States Patent and Trademark Office, P.O. Box 1450, Alexandria VA 22314.

Bai, Lihui, Washington, DC
Banner, Brian Christopher, Austin, TX
Baraldi, Thomas Michael, Clayton, NC
Barras, Dalgis, Conroe, TX
Bench, Meriel Lianna, San Diego, CA
Boskovic, Filip, Toronto, ON, Canada
Cairns, Ryan William, Dallas, TX
Choi, Jaeyoung, San Diego, CA
Diehl, Isabella Ann, Brookline, MA
Duncan, Sydney Grace, Chicago, IL
Emori, Eita, Seattle, WA
Gauthier, John Michael, Boise, ID
Gierl, Paul Robert, South Bend, IN
Gonzalez Lopez, Marcos, San Diego, CA
Gu, Hangbo Gong, Mountain View, CA
Hanger, Clara Ann, Aiken, SC
Joyce, Rosalynd Ruby-Michelle, Greenville, NC
Kava, Alyssa Ann, Denver, CO
Koenigsknecht, Luke Patrick, Chicago, IL
Kohls, Isa Mary, Murray, UT
Lucarelli, Ronald Vittorio, Aurora, IL
Mass, Zachary Martin, Iowa City, IA
Michael, Jonathan Kirin, Houston, TX
Opdahl, Bennington David, Erdenheim, PA
Pales, Jacob Eugene, Columbus, NE
Pham, Timmy Vu, Seattle, WA
Riegel, Bryce Evans, Falls Church, VA
Ruppel, Matthew James, Lynnwood, WA
Schuler, Joseph Thomas, Liverpool, NY
Soyring, Joanna Marie, Long Beach, CA
Trieu, Cindy Ann, Clawson, MI
Valdes, Lucas Carl, Somerville, MA
VandeVort, Peter David, Ann Arbor, MI
Vo, Kim, Littleton, CO
Welsh, Kelly Anne, McLean, VA
Williams, Benjamin Eugene, Hopkins, MN
Williams, Elliott Todd, Sierra Vista, AZ
Young, Jonathon Bennett, Madison, WI

William R. Covey
Deputy General Counsel for Enrollment and Discipline and
Director of the Office of Enrollment and Discipline

April 16, 2024